

Transaction Information

Tool ID	PNIT-02
Tool Status	Running Wafers
Location	Woodlands, Singapore
Wafer Size	200 mm
Fab Section	Etch
Tool Available Date	2024-01-31

General Product Information

Vendor Supplier	LAM
Model	LAM RAINBOW 4428
Vintage	1994
Serial No	3533
Asset Description	LAM 4420 ETCHER
Software Version	Envision1.5-Release
CIM	SECS
Process	CMOS

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	LAM 4420 ETCHER	1	
Handler System	Harmonics Arm	2	
Factory Interface	SMIF	2	
Options System			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
LL Pump	1	
TCU 2080	1	
AC Rack	1	
PC Pump	1	

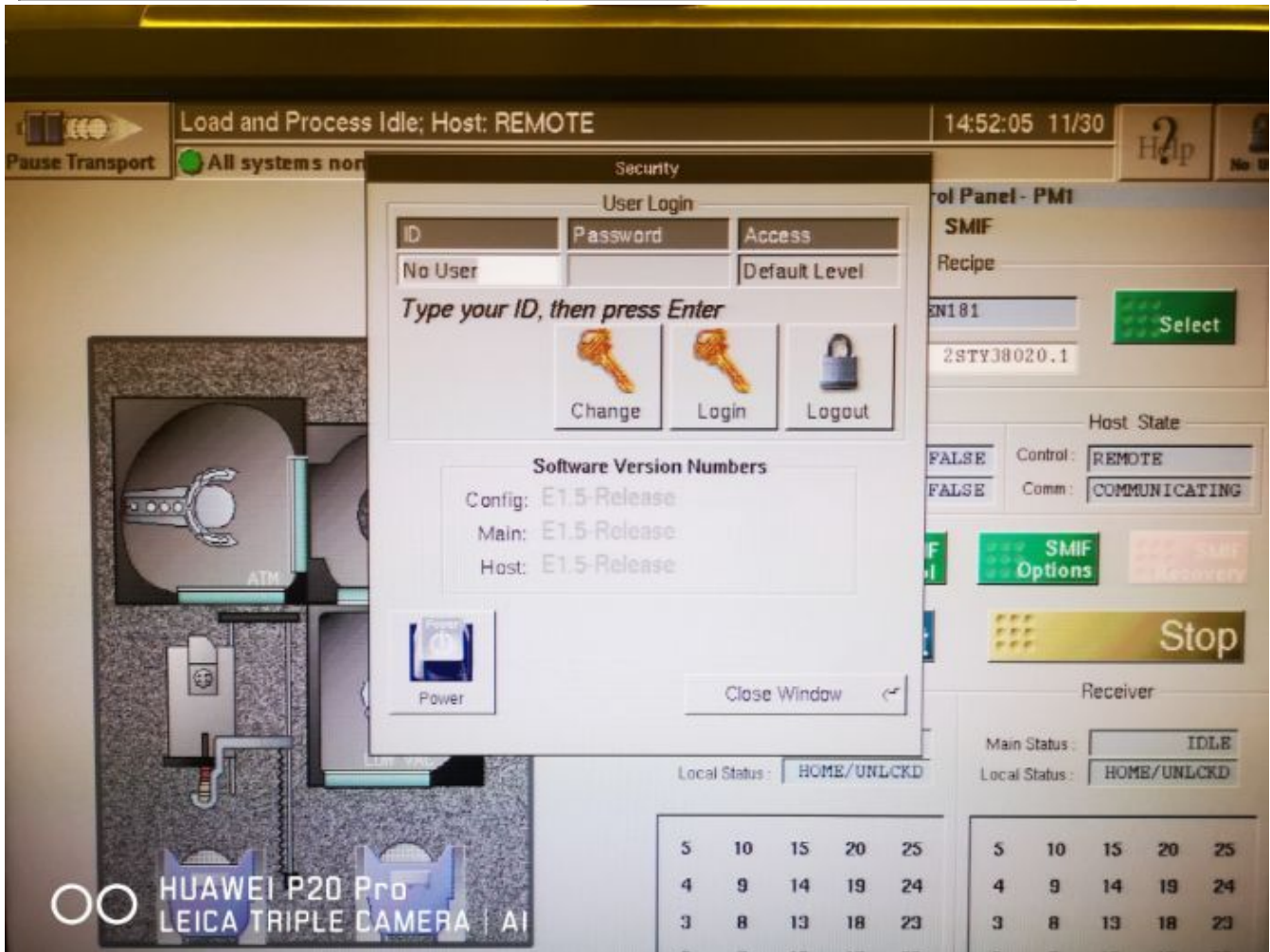
Missing/Faulty Parts / Accesories List

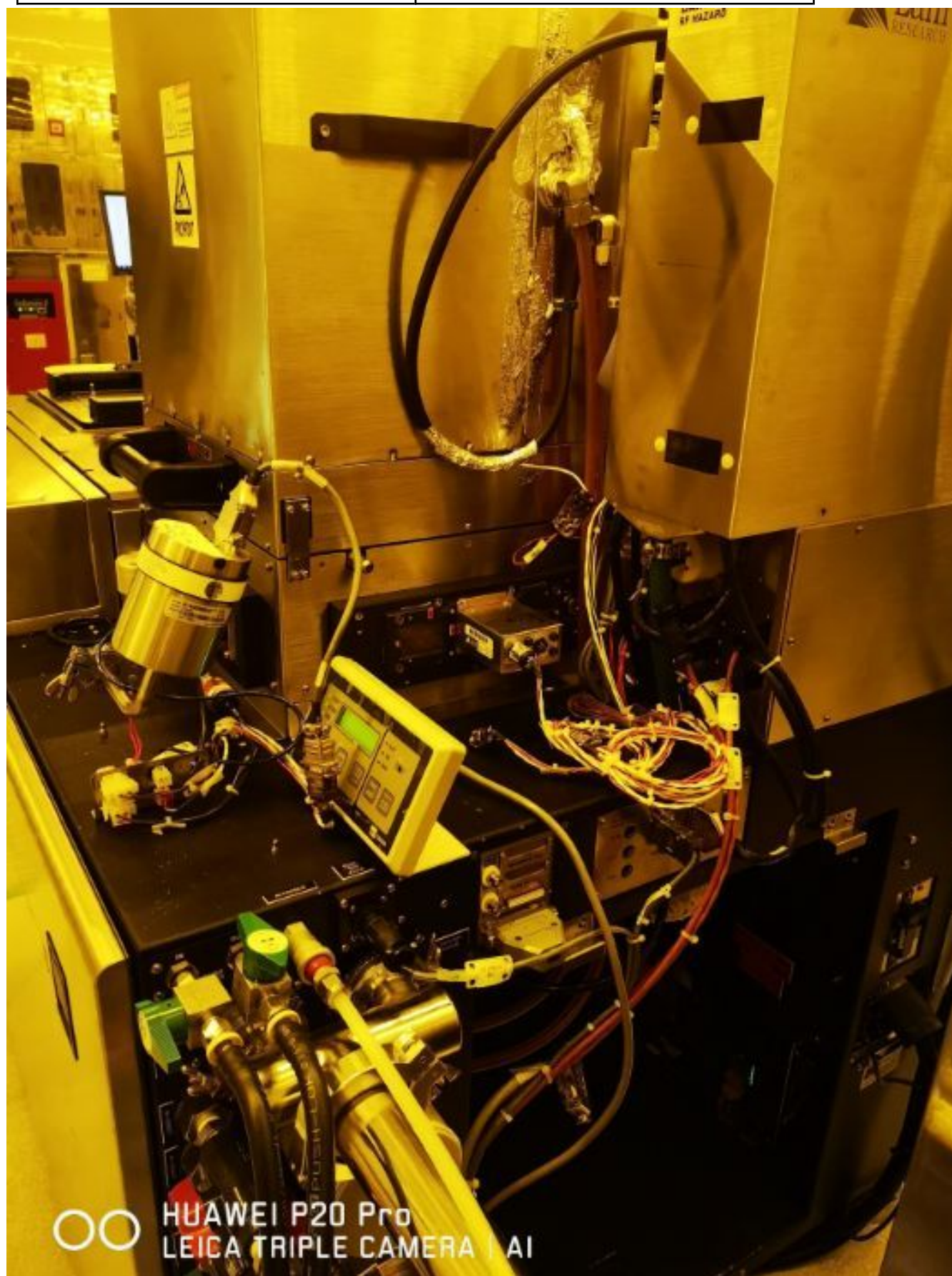
Description	Quantity
NONE	

Tool Pictures

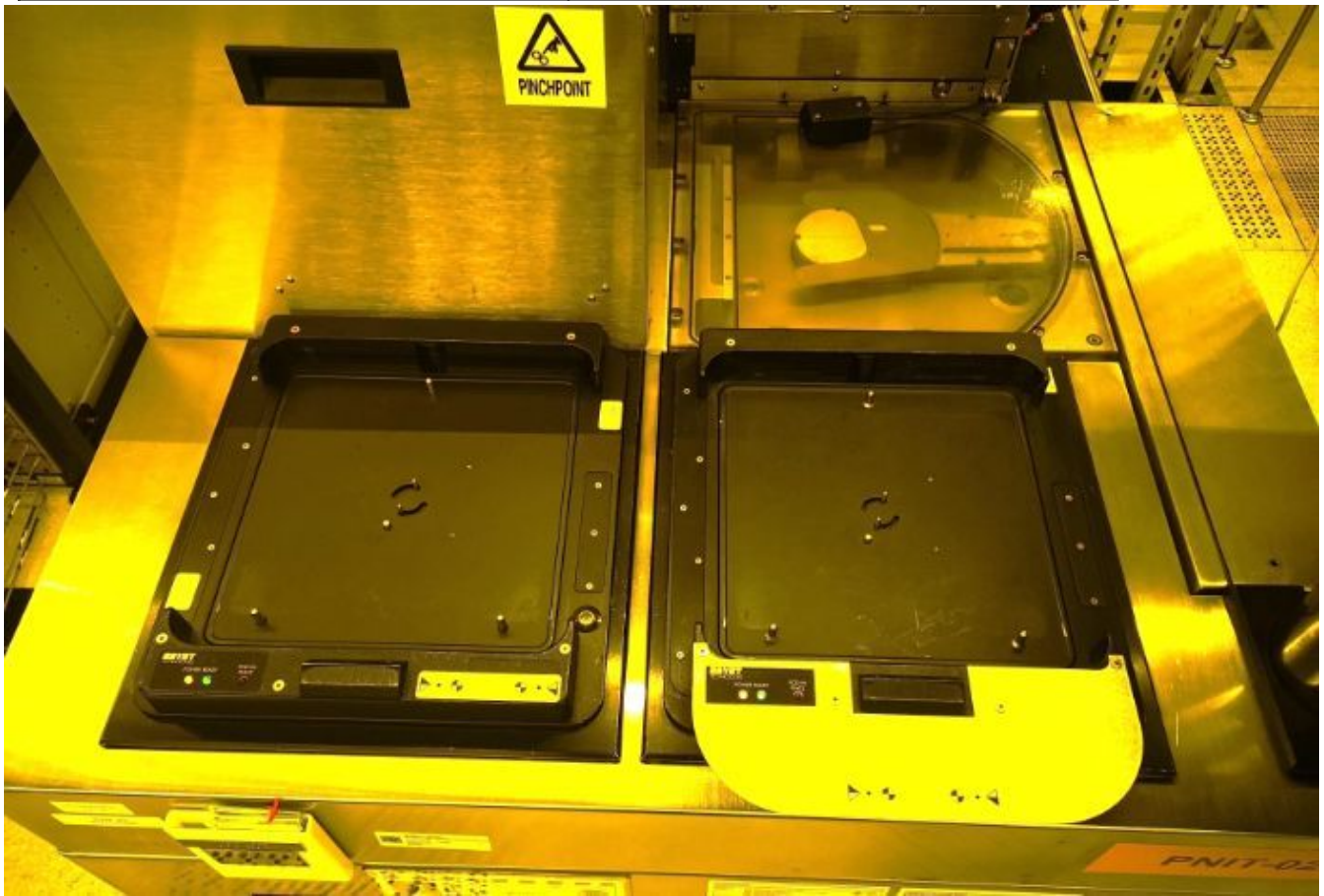
Hardware Fab

PNIT02 Fab





○ ○ HUAWEI P20 Pro
LEICA TRIPLE CAMERA | AI













Manufacture Serial

PNIT02 Serial No



Additional Configuration Files